

<b>INFORMATION DISCLOSURE</b> <b>STATEMENT BY APPLICANT</b> Substitute for form 1449/PTO  Sheet 1 of 1	Application Number	10/606,043
	Filing Date	6/25/2003
	First Named Inventor	Simon C. CHU
	Art Unit	2141
	Examiner Name	Rupal Dharia COULTER
	Attorney Docket Number	RPS920030076US1

### U.S. PATENT DOCUMENTS

Examiner Initials	Cite No. <sup>1</sup>	Document Number	Publication Date	Name of Patentee or Applicant of Cited Document	Pages/Columns/Lines Where Relevant Passages Appear
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		6,185,623	02/06/2001	Bailey et al.	
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### FOREIGN PATENT DOCUMENTS

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	Filing Date		2003-06-25
	First Named Inventor	Simon C. Chu	
	Art Unit	2141	
	Examiner Name	Rupal Dhanra <b>COULTER</b>	
	Attorney Docket Number	RPS920030076US1	

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1111	1	2001-518665	JP	T2	2001-10-16			<input type="checkbox"/>
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	Art Unit	2141	
	Examiner Name	<del>Rupel Dharia</del> <b>COULTER</b>	
	Attorney Docket Number	RPS920030076US1	

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